

JAN 23 2002

## TRANSMITTAL OF FORMAL DRAWINGS

Docket No.  
FIS9-2001-01561762  
#3

In Re Application Of: DANIEL C. EDELSTEIN ET AL

Serial No.	Filing Date	Batch No.	Examiner	Art Unit
10/005861	11/08/2001			

Invention: LOW K DIELECTRIC FILM DEPOSITION PROCESS

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JAN 28 2002

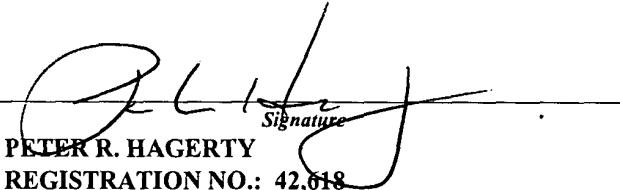
Address to:  
Assistant Commissioner for Patents  
Washington, D.C. 20231

TC 1700

Transmitted herewith are:

4 sheets of formal drawing(s) for this application.

Each sheet of drawing indicates the identifying indicia suggested in 37 CFR Section 1.84(c) on the reverse side of the drawing.

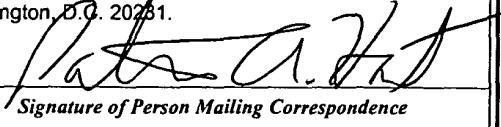
  
Signature

PETER R. HAGERTY  
REGISTRATION NO.: 42,618  
CUSTOMER NO. 23413

Dated: JANUARY 2, 2002

I certify that this document and attached formal drawings are being deposited on 01/02/2002 with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

Signature of Person Mailing Correspondence

  
PATRICIA A. HART  
Typed or Printed Name of Person Mailing Correspondence